

Layered group-IV-V-VI semiconductors with superior piezoelectricity and ferroelectricity

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Supplementary Material

S1. Various stacking configurations of bilayer SnP_2Se_6

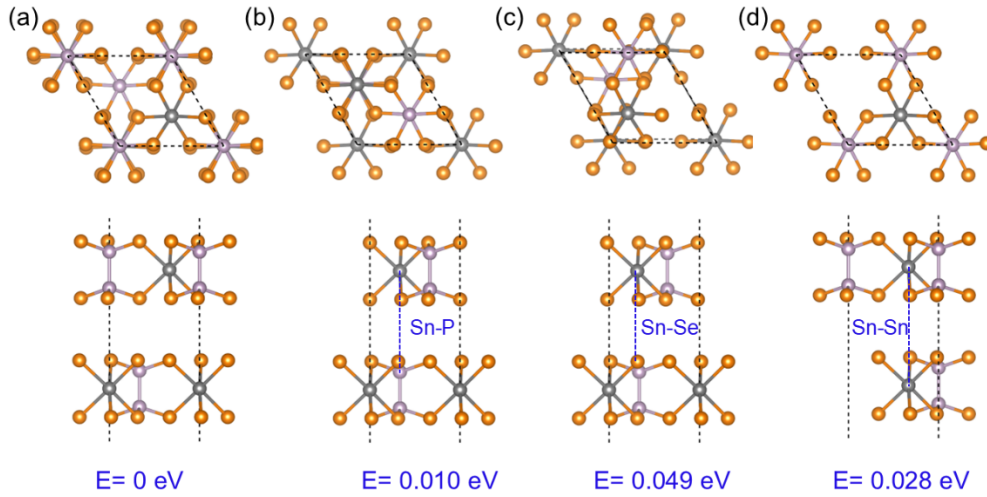


Fig. S1 Various stacking configurations of bilayer SnP_2Se_6 . (a-d) correspond to configurations where the upper Sn atom is positioned over a vacancy, and over P, Se, and Sn atoms in the lower layer, respectively. Taking the structure in (a) as the reference (0 eV), the other three stacking configurations have higher energies.

S2. Various stacking configurations of bilayer SnP_2Se_6

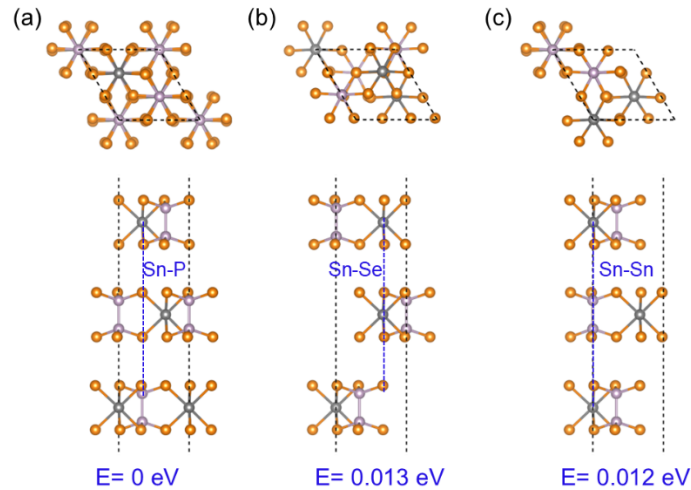


Fig. S2. Various stacking configurations of trilayer SnP_2Se_6 . (a-c) correspond to configurations where the upper Sn atom is positioned over P, Se, and Sn atoms in the lower layer, respectively. Taking the structure in (a) as the reference (0 eV), the other stacking configurations have higher energies.

S3. Thermodynamic Stability of monolayer SnP_2Se_6

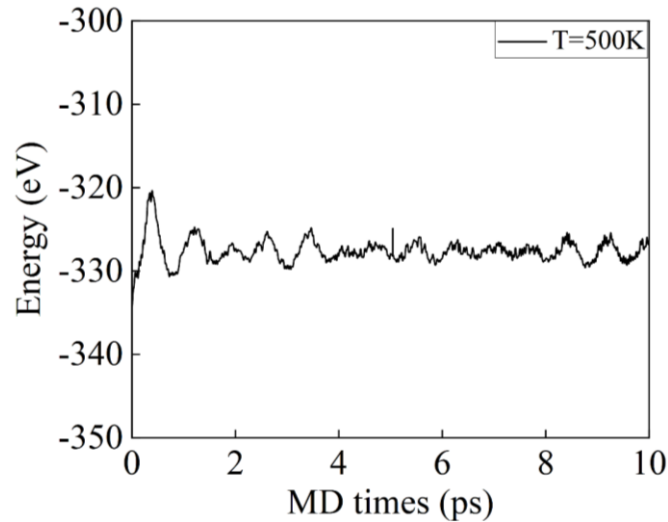


Fig. S3. Variations of energy with the time of AIMD simulation for the monolayer SnP_2Se_6 with temperature controlled at 300 K.

S4. AIMD simulations of O_2 collision with SnP_2Se_6 monolayer at 300 K

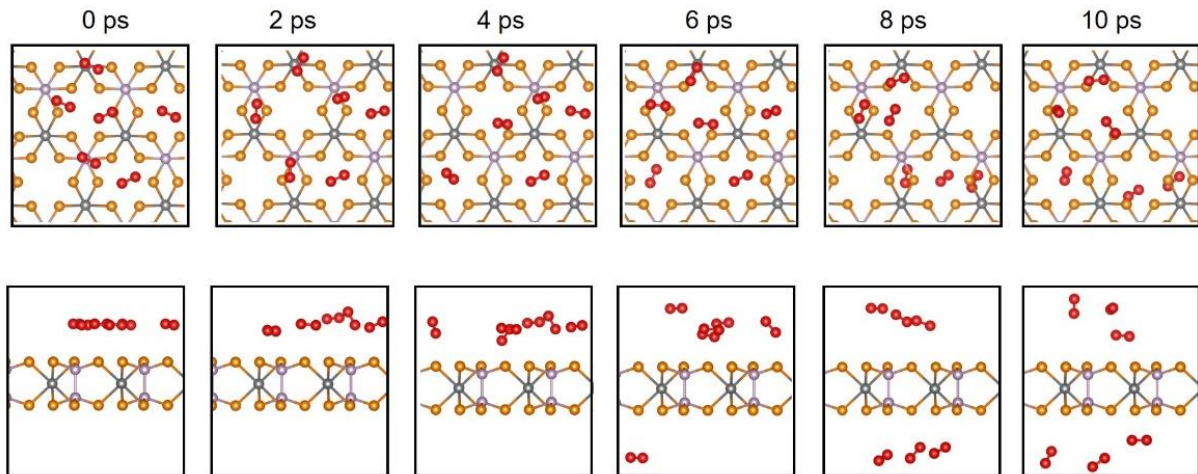


Fig. S4. Snapshots of AIMD simulations of O_2 oxidation at 300 K at 2 -10 ps. It can be seen that O_2 molecules are typically bounced back to the vacuum after collision with the SnP_2Se_6 monolayer. Hence, it seems that SnP_2Se_6 monolayer exhibits superior oxidation resistance.

S5. Adsorption structure of water on group-IV-V-VI monolayer surface

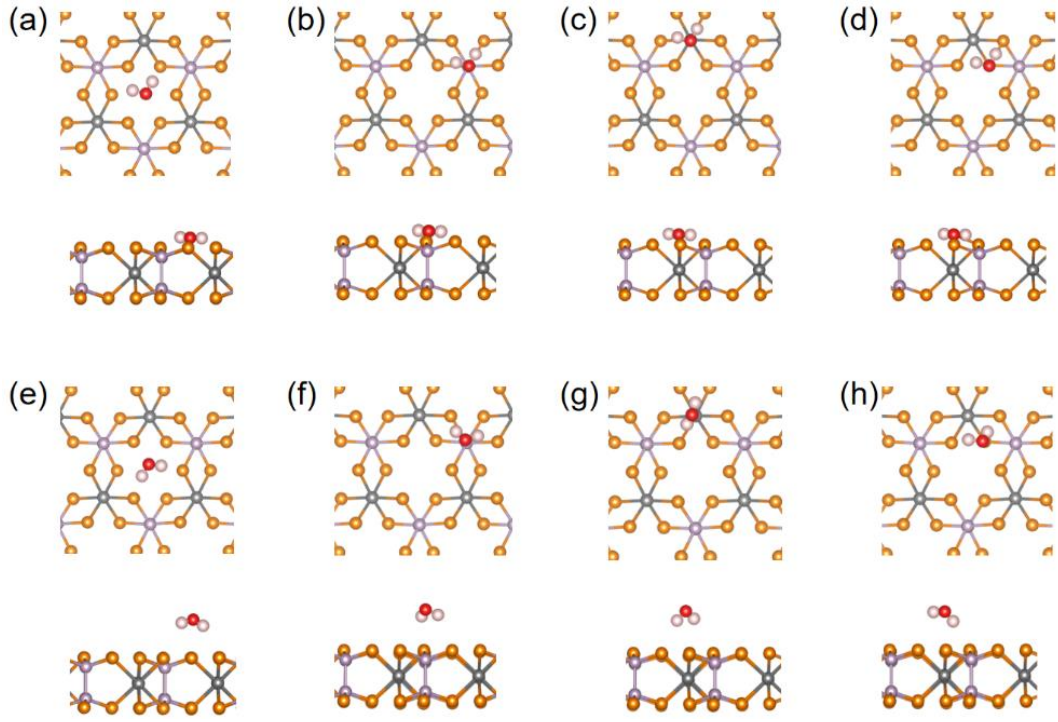


Fig. S5. (a-d) show the pre-optimization structures with the water molecule placed at four inequivalent adsorption sites on the SnP_2Se_6 surface: the center of a hexagonal ring and the top sites of three different atoms; (e-h) show the post-optimization structures, where all atomic distances are greater than 2.5 Å.

S6. Phonon dispersions of group-IV-V-VI monolayers

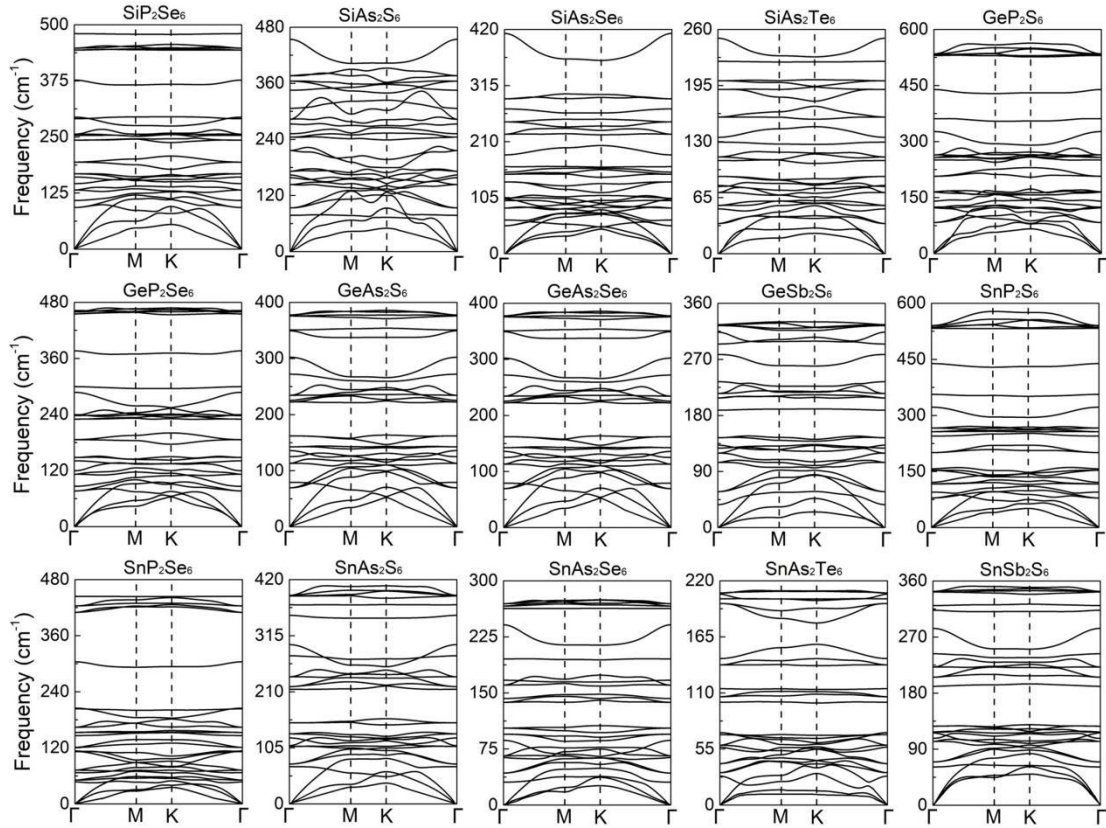


Fig. S6. Phonon dispersions of group-IV-V-VI monolayers.

S7. Elastic constants for the group-IV-V-VI monolayers

Table S1. Elastic constants for the group-IV-V-VI monolayers.

Materials	C_{11}	C_{12}	C_{13}	C_{14}	C_{33}	C_{44}
SiP ₂ Se ₆	44.32	13.89	0.54	0.11	0.08	0.07
SiAs ₂ S ₆	46.00	15.75	0.61	1.02	0.11	0.14
SiAs ₂ Se ₆	33.61	13.22	0.88	0.09	0.09	0.12
SiAs ₂ Te ₆	21.11	5.85	0.57	0.22	0.03	0.05
GeP ₂ S ₆	48.23	11.36	0.44	0.33	0.07	0.06
GeP ₂ Se ₆	37.04	10.15	0.36	0.25	0.11	0.13
GeAs ₂ S ₆	40.32	12.13	1.6	1.45	0.58	0.77
GeAs ₂ Se ₆	39.65	10.75	1.13	1.21	0.41	0.18
GeSb ₂ S ₆	30.36	11.09	0.08	0.04	0.03	0.06
SnP ₂ S ₆	42.44	8.12	0.37	0.32	0.08	0.09
SnP ₂ Se ₆	30.25	5.99	0.16	0.12	0.04	0.05
SnAs ₂ S ₆	33.55	8.77	1.05	0.17	0.2	0.08
SnAs ₂ Se ₆	25.41	8.20	0.85	0.3	0.3	0.16
SnAs ₂ Te ₆	32.04	18.10	0.11	0.10	0.05	0.07
SnSb ₂ S ₆	28.58	6.84	0.14	0.12	0.03	0.04

S8. Band structures of group-IV-V-VI monolayers

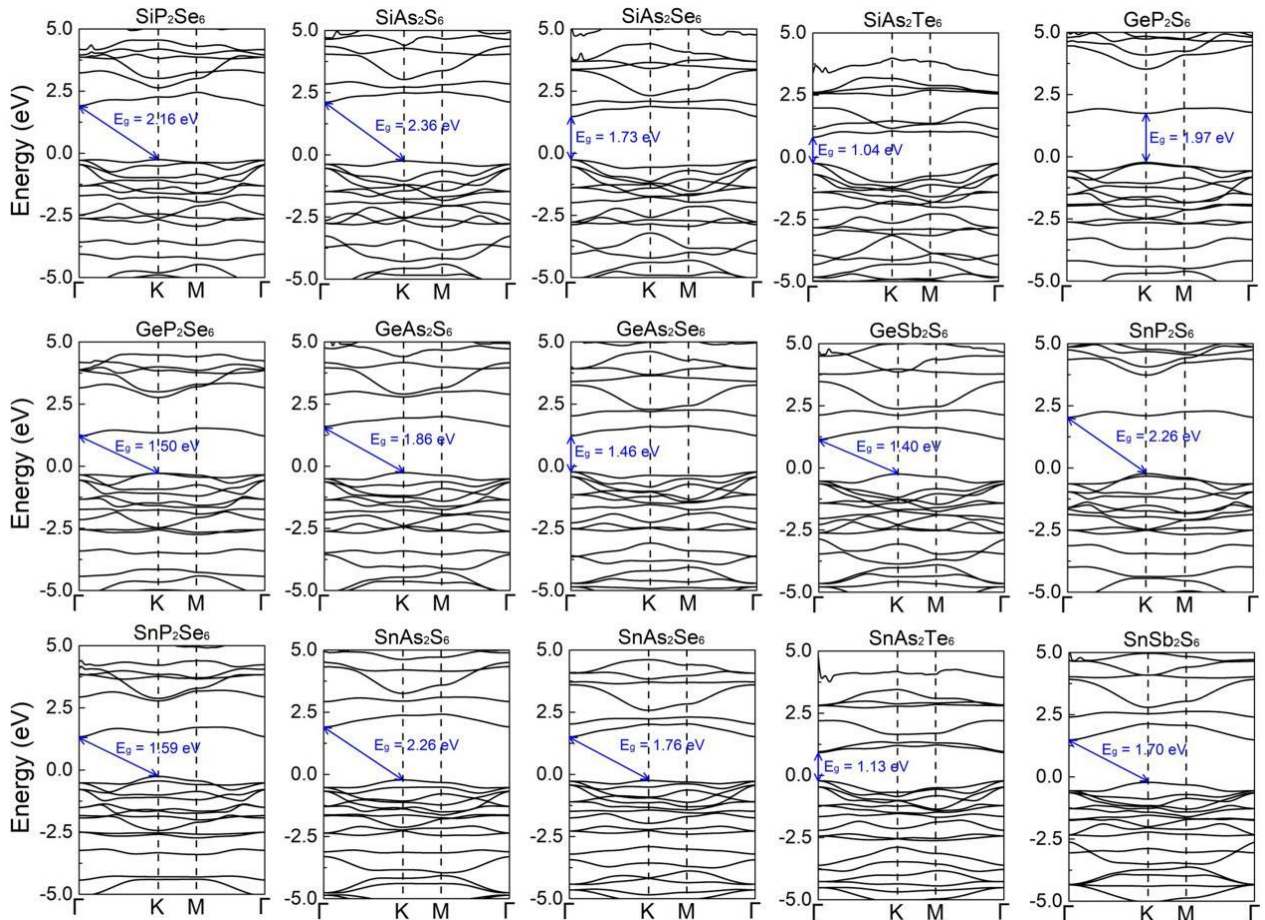


Fig. S7. Band structures of group-IV-V-VI monolayers.

S9. Phonon dispersion for the paraelectric phase of monolayer SnP_2Se_6

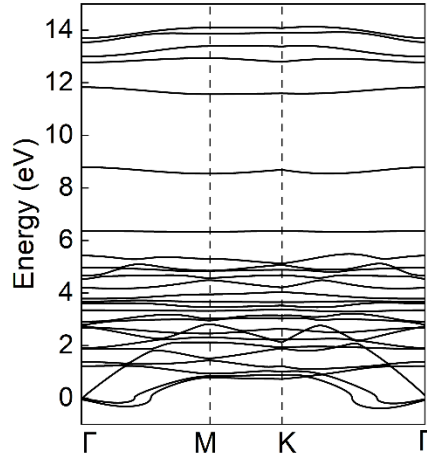


Fig. S8. Phonon dispersions for the paraelectric phase of SnP_2Se_6 .

S10. Piezoelectric coefficients of SiAs_2Te_6

Table S2. The lattice constant a (Å), the vdW interlayer gap h (Å), elastic constants C_{11} and C_{12} (N/m) and piezoelectric coefficients d_{11} , d_{22} , d_{31} and d_{33} (pm/V) of SiAs_2Te_6 .

SiAs_2Te_6	Monolayer	Bilayer	Trilayer
Point group	32	3	3
a	7.15	7.01	7.00
h	--	3.39	3.38
C_{11}	21.11	49.13	106.21
C_{22}	21.11	46.15	104.29
C_{12}	5.85	28.60	49.01
d_{11}	22.94	12.22	10.77
d_{22}	--	0.16	0.17
d_{31}	--	0.88	1.52
d_{33}	--	9.29	11.52

S11. Double-well potential versus polarization and AIMD simulations for SiAs_2Te_6 monolayer

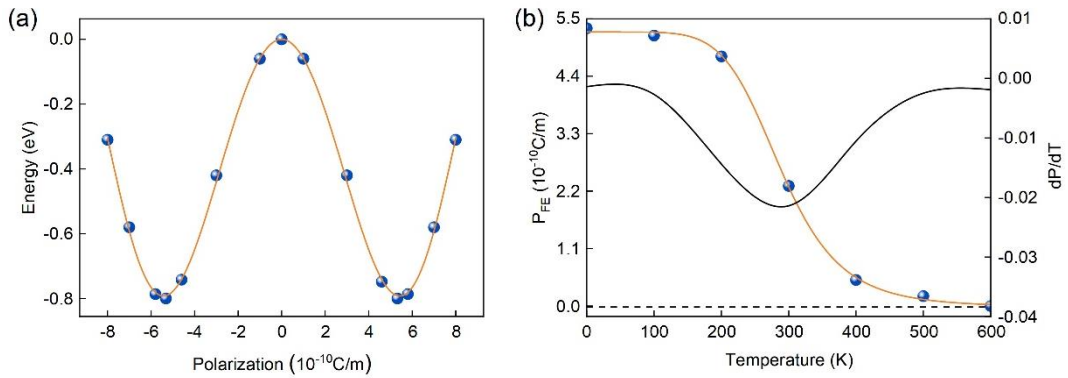


Fig. S9. (a) Double-well potential versus polarization for SiAs₂Te₆ monolayer. (b) Temperature dependence of polarization obtained from ab initio molecular dynamics (orange balls). Orange line is a sigmoid fit to MD results and grey line is the pyroelectric response (dP/dT) for SiAs₂Te₆ monolayer.